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APPLICANT(S)
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U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE

U.S. PATENT APPLICATION PUBLICATIONS

	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	

U.S. PATENT APPLICATIONS

	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
/RD/	JP 4-153792	05/27/1992	Japan (Full Japanese Text & English Abstract)			X	
	JP 4-213129	08/04/1992	Japan (Full Japanese Text & English Abstract)			X	
	JP 6-282702	10/07/1994	Japan (Full Japanese Text & English Abstract)			X	
	JP 7-191892	07/28/1995	Japan (Full Japanese Text & English Abstract)			X	
	JP 9-231110	09/05/1997	Japan (Full Japanese Text & English Abstract)			X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)

/RD/	Japanese Office Action dated August 21, 2008

EXAMINER /Ryan Dare/

DATE CONSIDERED 01/19/2009

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /RD/